



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**In re application of:**

Brian K. Aegerter et al.

**Application No.** 10/632,495

**Filed:** July 31, 2003

**Confirmation No.** Not yet assigned

**For:** SELECTIVE TREATMENT OF  
MICROELECTRONIC WORKPIECE  
SURFACES

**Examiner:** Not yet assigned

**Art Unit:** Not yet assigned

**Attorney Reference No.** 6884-66364

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Attorney  
for Applicant(s)

Date Mailed

*[Handwritten signature]*  
1/15/04

**INFORMATION DISCLOSURE STATEMENT**  
**FOR CONTINUING APPLICATIONS**

Listed on the accompanying form PTO-1449 are several English-language documents.

Applicants respectfully request that such documents be listed as references cited on the issued patent.

The present application relies upon U.S. Patent Application No. 09/672,572, which was filed September 28, 2000, for an earlier filing date under 35 U.S.C. § 120. Furthermore, documents listed on the accompanying form PTO-1449 were disclosed to or cited by the Patent Office in the earlier U.S. application.

Copies of the documents listed on the accompanying form PTO-1449 that were cited by applicants in the earlier application need not be sent to the Patent Office pursuant to 37 C.F.R. § 1.98. However, applicants will furnish the Patent Office with such copies upon request.

Copies of documents listed on the accompanying form PTO-1449 that were cited by the Patent Office in the earlier application are enclosed.

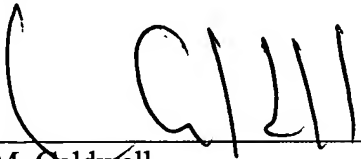
Please charge any additional fees that may be required in connection with filing this Information Disclosure Statement, or credit any overpayment, to Deposit Account No. 02-4550. A duplicate copy of this sheet is enclosed.

The filing of this Information Disclosure Statement shall not be construed to be an admission that the information cited in the statement is, or is considered to be, prior art or otherwise material to patentability as defined in 37 C.F.R. §1.56.

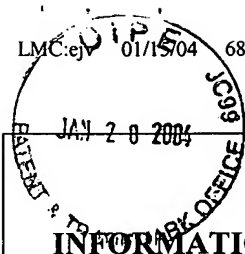
Respectfully submitted,

KLARQUIST SPARKMAN, LLP

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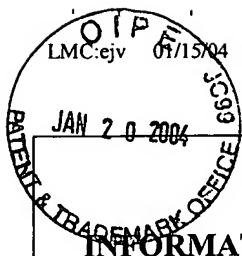
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		3,664,933	5/1972	Clauss
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		4,315,059	2/1982	Raistrick et al.
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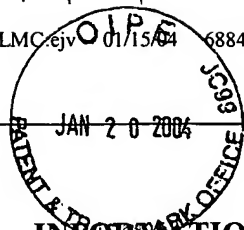
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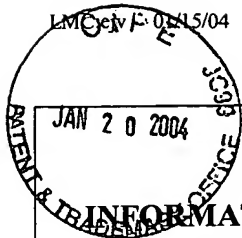
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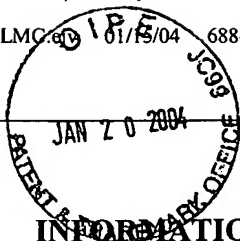
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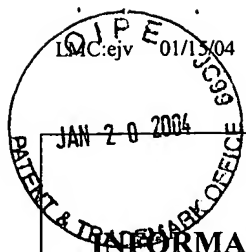
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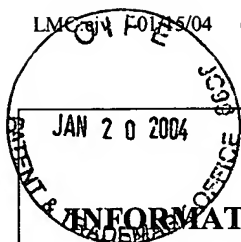
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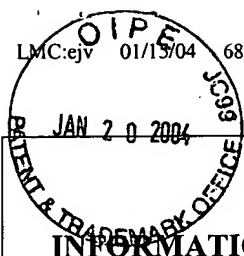
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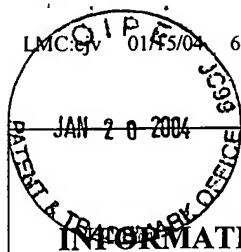
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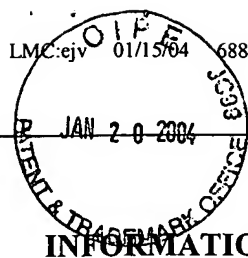
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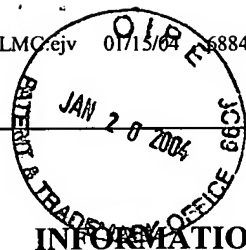
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		5-21332	1/1993	JP

EXAMINER  
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\* Examiner: Initial if reference considered, whether or not in conformance with MPEP 609. Draw line through cite if not in conformance and not considered. Include copy of this form with next communication to applicant.



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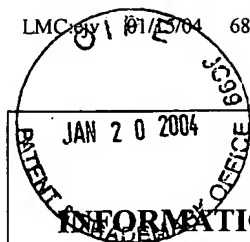
<b>Attorney Docket Number</b>	6884-66364
<b>Application Number</b>	10/632,495
<b>Filing Date</b>	July 31, 2003
<b>First Named Inventor</b>	Brian K. Aegerter
<b>Art Unit</b>	Not yet assigned
<b>Examiner Name</b>	Not yet assigned

		5-13322	1/1993	JP
		5-326483	12/1993	JP
		6-17291	1/1994	JP
		6-45302	2/1994	JP
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		WO 98/27585	6/1998	WIPO
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<b>Examiner's Initials*</b>	<b>Cite No. (optional)</b>	<b>OTHER DOCUMENTS</b>		
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